

	Application No.	Applicant(s)	_
Notice of Allowability	10/823,990	WANG ET AL.	
	Examiner	Art Unit	
	Andy Huynh	2818	
The MAILING DATE of this communication apperation apperation allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet w (OR REMAINS) CLOSED or other appropriate comm GHTS. This application is	in this application. If not included nunication will be mailed in due course. THIS	tive
1. 🔀 This communication is responsive to the Amendment and I	Election dated 10/19/05.		
2. X The allowed claim(s) is/are 1-55.			
 3. Acknowledgment is made of a claim for foreign priority unerset a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 	been received. been received in Applicat	on No	
3. Copies of the certified copies of the priority do	cuments have been receive	ed in this national stage application from the	
International Bureau (PCT Rule 17.2(a)).		•	
* Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to fi IENT of this application.	e a reply complying with the requirements	
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXes reason(s) why the oath	AMINER'S AMENDMENT or NOTICE OF or declaration is deficient.	
5. CORRECTED DRAWINGS (as "replacement sheets") mus			
(a) I including changes required by the Notice of Draftspers		w (PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on he header according to 37 C	the drawings in the front (not the back) of FR 1.121(d).	
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT	SIT OF BIOLOGICAL MATERIES OF B	ERIAL must be submitted. Note the OLOGICAL MATERIAL.	
Attachment(s) 1. ⊠ Notice of References Cited (PTO-892)	5 🗀 Notice of I	nformal Patent Application (PTO-152)	
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)		Summary (PTO-413),	
3. ⊠ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No	./Mail Dates Amendment/Comment	
Paper No./Mail Date <u>01/03/05</u> 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner' 9. □ Other	s Statement of Reasons for Allowance	
		Andy Mugh Andy Hughl Patent Examine	
		Patent Examiner	

DETAILED ACTION

In the Amendment dated 10/19/2005, Claims 45-50 have been amended, and new Claim 55 is added.

Election/Restrictions

Claims 1-11 and 45-50 are directed to an allowable product. Pursuant to the procedures set forth in the Official Gazette notice dated March 26, 1996 (1184 O.G. 86), Claims 12-22 and 35-44, directed to the process of making or using the patentable product, previously withdrawn from consideration as a result of a restriction requirement, are now subject to being rejoined. Claims 12-22 and 35-44 are hereby rejoined and fully examined for patentability under 37 CFR 1.104.

Since all claims previously withdrawn from consideration under 37 CFR 1.142 have been rejoined, the restriction requirement made in the previous Office action is hereby withdrawn.

Accordingly, Claims 1-55 are pending in the application.

Allowable Subject Matter

Claims 1-55 are allowed.

The following is an examiner's statement of reason for allowance:

Claims 1-11 and 45-50 are allowable over the prior art of record because the prior art of record does not teach or render a Si/C superlattice useful for semiconductor devices comprises a plurality of epitaxially grown silicon layers alternating with carbon layers respectively adsorbed on surfaces of the silicon layers as recited in independent Claim 1.

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Claims 12-44 and 51-54 are allowable over the prior art of record because the prior art of record does not teach or render a structure useful for electronic or opto-electronic devices comprises a Si/C superlattice comprising a plurality of epitaxially grown silicon layers alternating with carbon layers respectively adsorbed on surfaces of the silicon layers, and in combination with all other features as recited in independent Claims 12, 23, 35 and 51.

Claim 55 is allowable over the prior art of record because the prior art of record does not teach or render a method for manufacturing low defect silicon carbide for use in semiconductor devices comprises providing a template consisting of a superlattice comprising a plurality of epitaxially grown silicon layers alternating with carbon layers respectively adsorbed on surfaces of the silicon layers, and in combination with all other features as recited in the claim.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andy Huynh whose telephone number is (571) 272-1781. The examiner can normally be reached on Monday-Friday 8:30am-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers for the

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organization where this application or proceeding is assigned are (571) 273-8300 for regular

communications and (703) 872-9306 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the receptionist whose telephone number is (703) 308-0956.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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10/28/05

Andy Huynh

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Patent Examiner